

PATENT
ATTORNEY DOCKET NO. 0099/004001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Satoshi MORIYA Art Unit:
Application No.: filed concurrently Examiner:
Filed : August 22, 2003
Title : RESISTIVE COMPOSITION, RESISTOR USING THE SAME,
AND MAKING METHOD THEREOF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to his duty of good faith and candor as set forth in 37 CFR 1.56(a), applicant requests that the enclosed references cited on attached form PTO-1449 be considered by the Examiner in connection with the search of the prior art required by 37 CFR 1.104.

Please note that the three Japanese references discussed on page 1 of the specification are submitted herewith. The English language abstracts of these Japanese references are also enclosed.

This Statement is being filed under 37 CFR 1.97(b) prior to the mailing date of a first Office Action on the merits.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached at the telephone number listed below.

Respectfully submitted,

R. A. Smith
Randolph A. Smith
Req. No. 32,548

Date: August 25, 2003

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Substitute for form 1449A/PTO		<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	Filed concurrently
		Filing Date	August 25, 2003
		Applicants	Satoshi MORIYA
		Group Art Unit	
		Examiner Name	
Sheet	1	of	1
		Attorney Docket Number	0099/004001

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

EXAMINER

DATE CONSIDERED

*Examiner: Initial if citation considered; whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible.

⁸Applicant is to place a check mark here if English language Translation is attached.

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